

1756

## PATENT

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

KO et al.

Application No: 09/894,230

Filed: June 27, 2001

For: APPARATUS AND METHOD FOR ARGON  
PLASMA INDUCED ULTRAVIOLET LIGHT  
CURING STEP FOR INCREASING SILICON-  
CONTAINING PHOTORESIST SELECTIVITY

Attorney Docket No: LAM2P257

Examiner: J. Ruggles

Group Art Unit: 1756

Date: June 2, 2003

RECEIVED  
JUN 10 2003  
TC 1700

Commissioner for Patents  
Washington, DC 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For Extra	Present	SMALL ENTITY RATE FEE	OR	LARGE RATE FEE	ENTITY
TOTAL				X09 = \$	OR	X18 = \$	
CLAIMS	09	-	36	00			
INDEP							
CLAIMS	01	-	05	00	X42 = \$	OR	X84 = \$
[ ] Multiple Dependent Claim Present and Fee Not Previously Paid				\$140		X280	\$
				TOTAL	\$_____		\$_____



Applicant(s) hereby petition for a month(s) extension of time to respond to the outstanding Office Action. Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805 (Order No. LAM2P257).



Enclosed is our Check No. in the amount of to cover the additional claim fee and/or extension of time fees.



If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM2P257). A copy of this sheet is enclosed.

Respectfully submitted,  
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